Notice of Allowability	Application No.	Applicant(s)
	10/621,522	OHNISHI, NORIAKI
	Examiner	Art Unit
	(Nancy) Thanh-Nhan P Nguyen	2871
The MAILING DATE of this communication appeal all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Report of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to <u>1/14/2005</u> .		
2. The allowed claim(s) is/are <u>1-10</u> .		
3. The drawings filed on 18 July 2003 are accepted by the Examiner.		
<ol> <li>Acknowledgment is made of a claim for foreign priority unas a) All b) Some* c) None of the:         <ol> <li>Certified copies of the priority documents have</li> <li>Certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ol> </li> <li>Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN.</li> </ol>	e been received. e been received in Application No cuments have been received in this of this communication to file a reply	national stage application from the
THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5. A SUBSTITUTE OATH OR DECLARATION must be submin INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER	
6. CORRECTED DRAWINGS (as "replacement sheets") mus  (a) including changes required by the Notice of Draftspers  1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Examiner'  Paper No./Mail Date  Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the second sheet.	st be submitted. son's Patent Drawing Review (PTO- s Amendment / Comment or in the C .84(c)) should be written on the drawin	948) attached  Office action of   ngs in the front (not the back) of
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT		
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date 7/18/2003</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. Interview Summary Paper No./Mail Dat 08), 7. Examiner's Amendr	te
4. Examiner's Comment Regarding Requirement for Deposit	<u> </u>	ent of Reasons for Allowance

## **DETAILED ACTION**

- 1. This communication is responsive to Amendment dated 1/14/2005.
- 2. Claims 1-10 are elected; claims 11-15 are cancelled.
- 3. Claims 1-10 are allowed.
- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Hara et al U.S. Patent No. 6,617,056 discloses a crystalline transparent conductive film substantially made of In-Sn-O. The crystalline part of the transparent conductive film (ITO-film) has a specific crystalline structure in which the X-ray diffraction intensity from the (222) crystal plane or the (440) crystal lane is highest, and [X440/222], the ratio of the X-ray diffraction intensity from the (440) crystal plane to that from the (222) crystal plane, is within the range of 0.2 to 2.5. It has a low resistivity, and useful as an electrode material for a liquid crystal display.

5. The following is an examiner's statement of reasons for allowance:

Applicant's claimed invention distinguishes over the prior art for the following reasons. The claims are allowable over the prior art of record because none of the references, either alone or in combination, discloses or renders obvious a liquid crystal display device comprising at least one <u>inorganic</u> <u>alignment film</u>, which is <u>made of a crystalline conductive film where crystal</u> <u>grains are oriented in a predetermined direction preferentially</u>.

Any comment considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to (Nancy) Thanh-Nhan P Nguyen whose telephone number is 571-272-1673. The examiner can normally be reached on M-F/9-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on 571-272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Brinish Exoner

February 18, 2005

TN